

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Hong Sick Park et al.	Examiner: Savitri Mulpuri
Serial No:	10/516,602	Group Art Unit: 2812
Filed:	July 5, 2005	Docket: 8071-152T (OPP 031969US)
For:	<b>A METHOD OF FORMING A METAL PATTERN AND A METHOD OF FABRICATING TFT ARRAY PANEL BY USING THE SAME</b>	

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action dated January 4, 2008, please amend the above-referenced patent application as set forth herein. Also, accompanying this amendment is a Request for Continued Examination (RCE).

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